

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Isabelle Chartier et al.

SERIAL NO.: 10/560,405

FILING DATE: December 12, 2005 CONFIRMATION NO.: 5533

TITLE: Method Of Bonding Microstructured Substrates

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AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Dear Sir:

This paper is responsive to the Final Office Action mailed April 22, 2008 and is accompanied by a Request for Continued Examination (RCE). Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.